

# Noise from birefringence fluctuations in laser interferometric gravitational wave detectors

Yuta Michimura

LIGO Lab, Caltech

[yuta@caltech.edu](mailto:yuta@caltech.edu)

RESCEU, UTokyo

[michimura@phys.s.u-tokyo.ac.jp](mailto:michimura@phys.s.u-tokyo.ac.jp)

Caltech



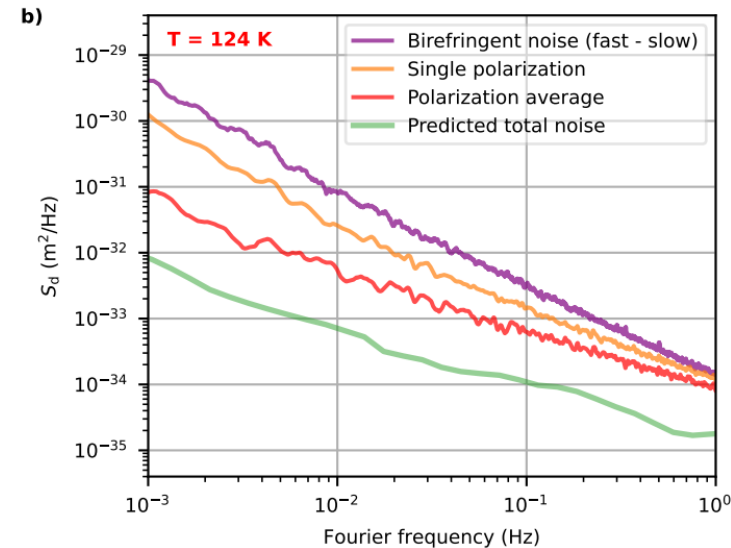
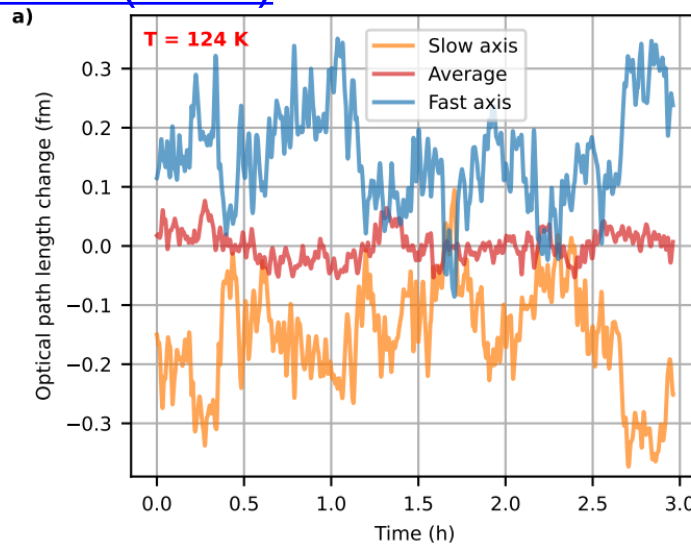
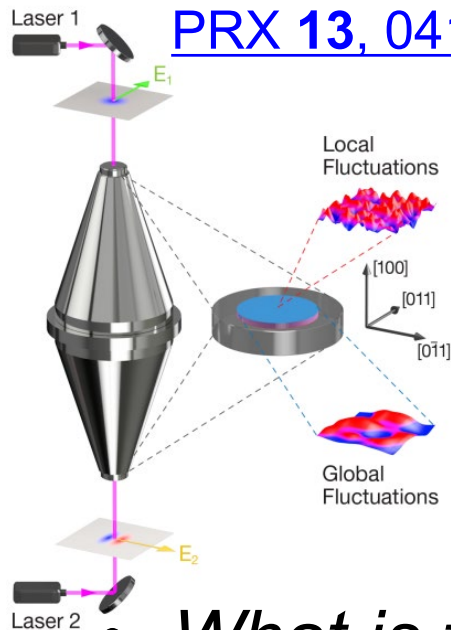
# Overview

- **Fluctuations in mirror birefringence** will be phase noises for GW detectors
- This can be avoided by aligning input polarization axis and mirror crystal axes
- Requirements at 100 Hz will be
  - $\Delta\varphi < \sim 10^{-8}$  rad/ $\sqrt{\text{Hz}}$  (or  $\Delta n < \sim 10^{-14}/\sqrt{\text{Hz}}$ ) for substrate
  - $\Delta\varphi < \sim 10^{-10}$  rad/ $\sqrt{\text{Hz}}$  for coating
- **Measurements and simulation work are necessary** for further study

Y. Michimura, H. Wang, F. Salces-Carcoba,  
C. Wipf, A. Brooks, K. Arai, R. X. Adhikari,  
[arXiv:2308.00150](https://arxiv.org/abs/2308.00150) (to appear in PRD)

# Birefringence Noise

- Crystalline materials (Silicon, Sapphire, AlGaAs etc.) are promising, but has birefringence
- Static birefringence is (probably) small enough e.g., [CQG 33, 015012 \(2015\)](#), [APL 122, 064101 \(2023\)](#)
- **JILA found “birefringent noise” in AlGaAs** [PRX 13, 041002 \(2023\)](#)

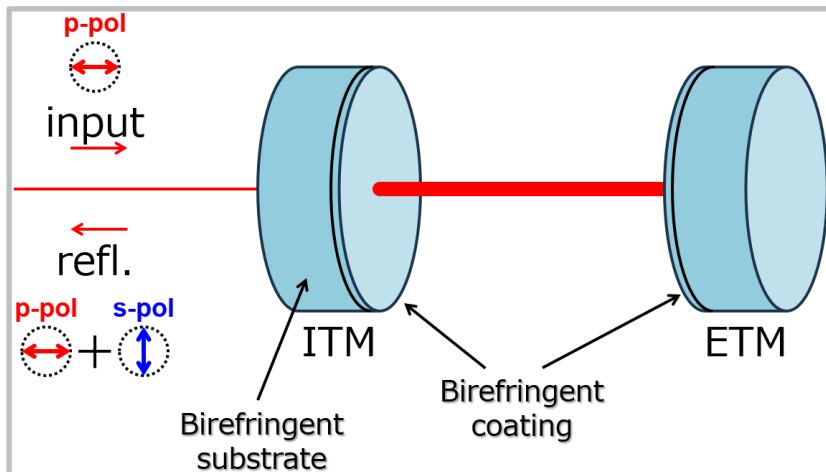


- *What is the requirement for mirror birefringence fluctuations for GW detectors?*

# Birefringent FP Cavity $\doteq$ FPMI

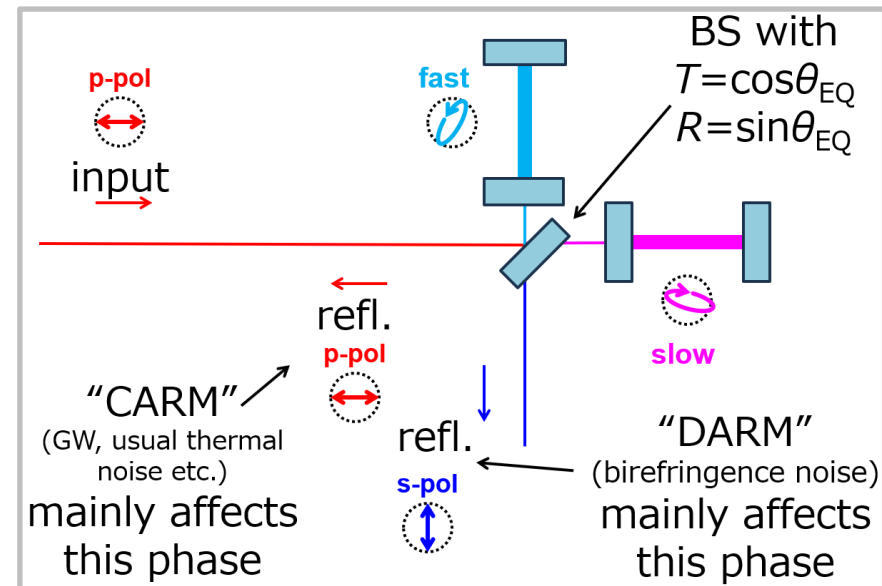
- Fabry-Pérot cavity with birefringent mirror can be understood as **unbalanced Fabry-Pérot Michelson**

## Birefringent FP Cavity



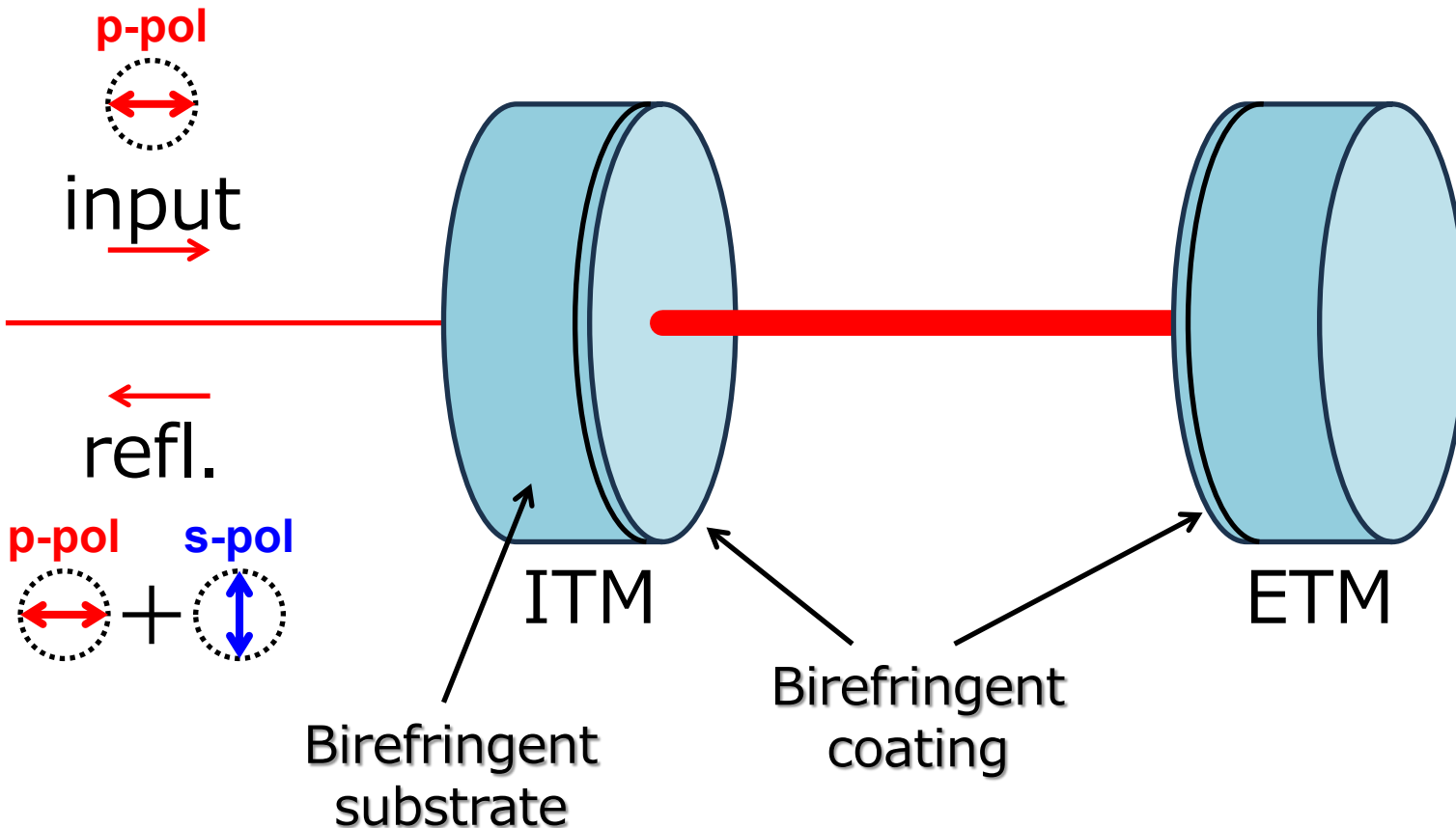
$\doteq$

## Unbalanced FPMI



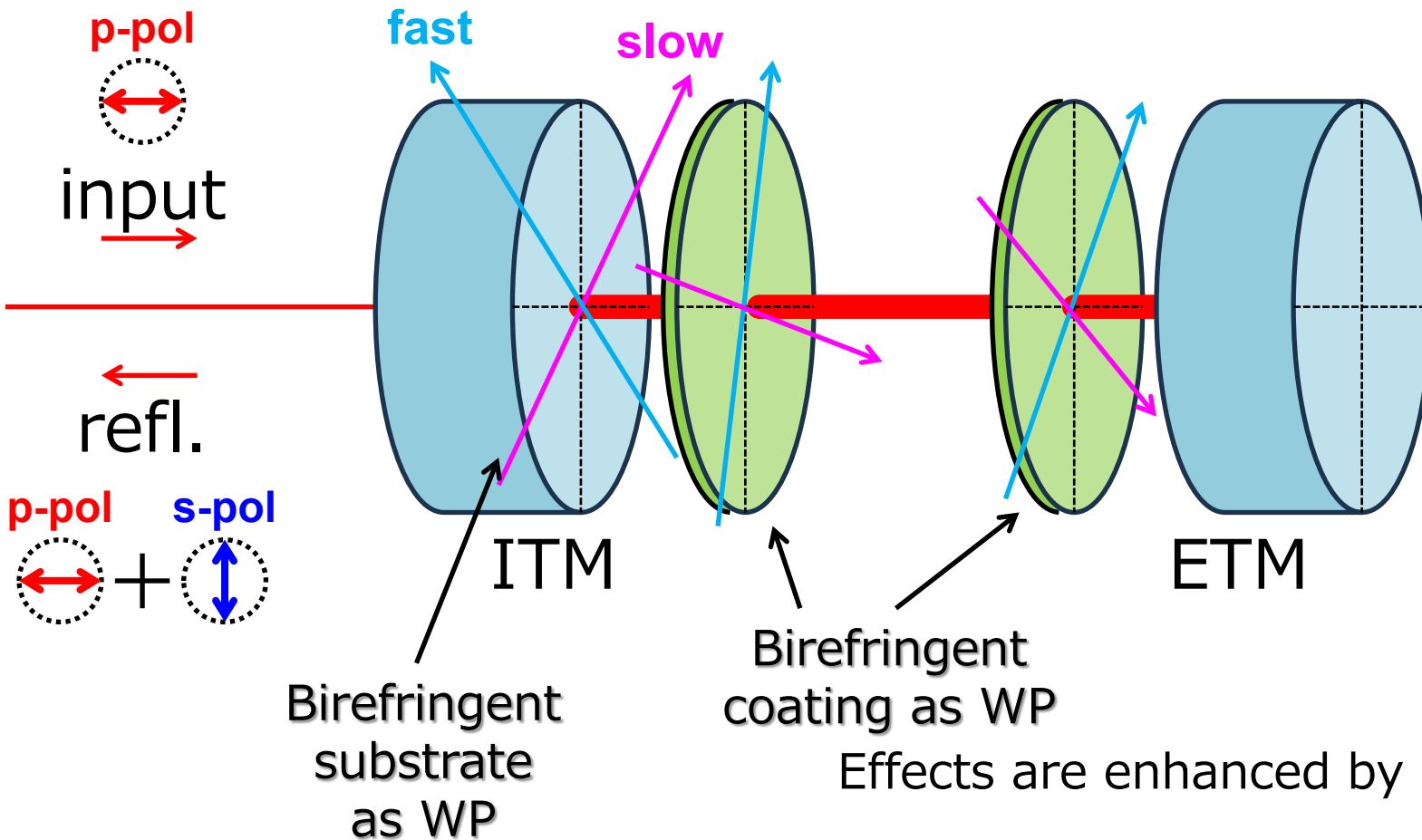
# Birefringent FP Cavity

- Consider a FP cavity with mirrors that have **substrate and coating birefringence**



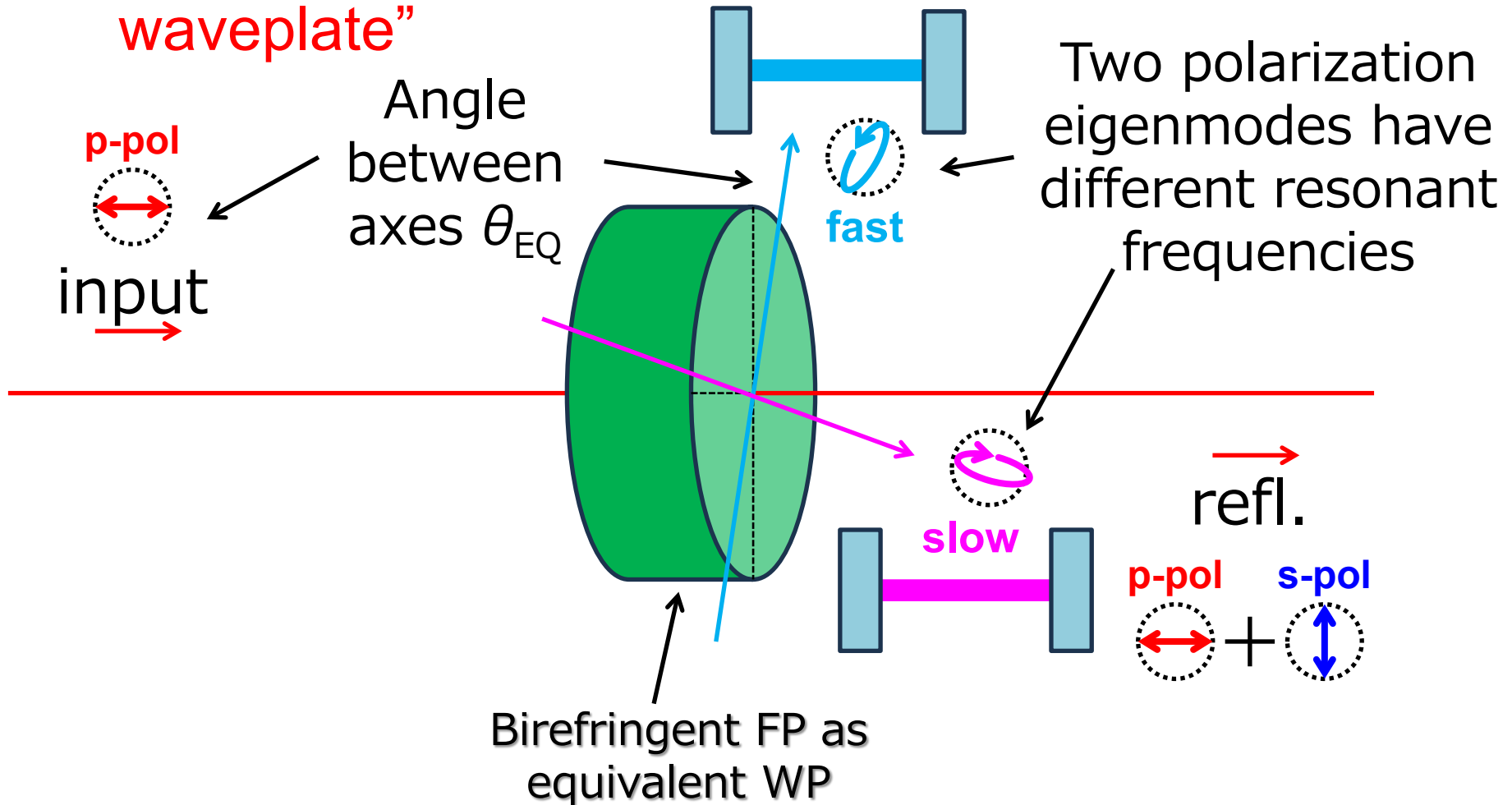
# Birefringent FP Cavity

- This is equivalent to FP cavity with **waveplates**



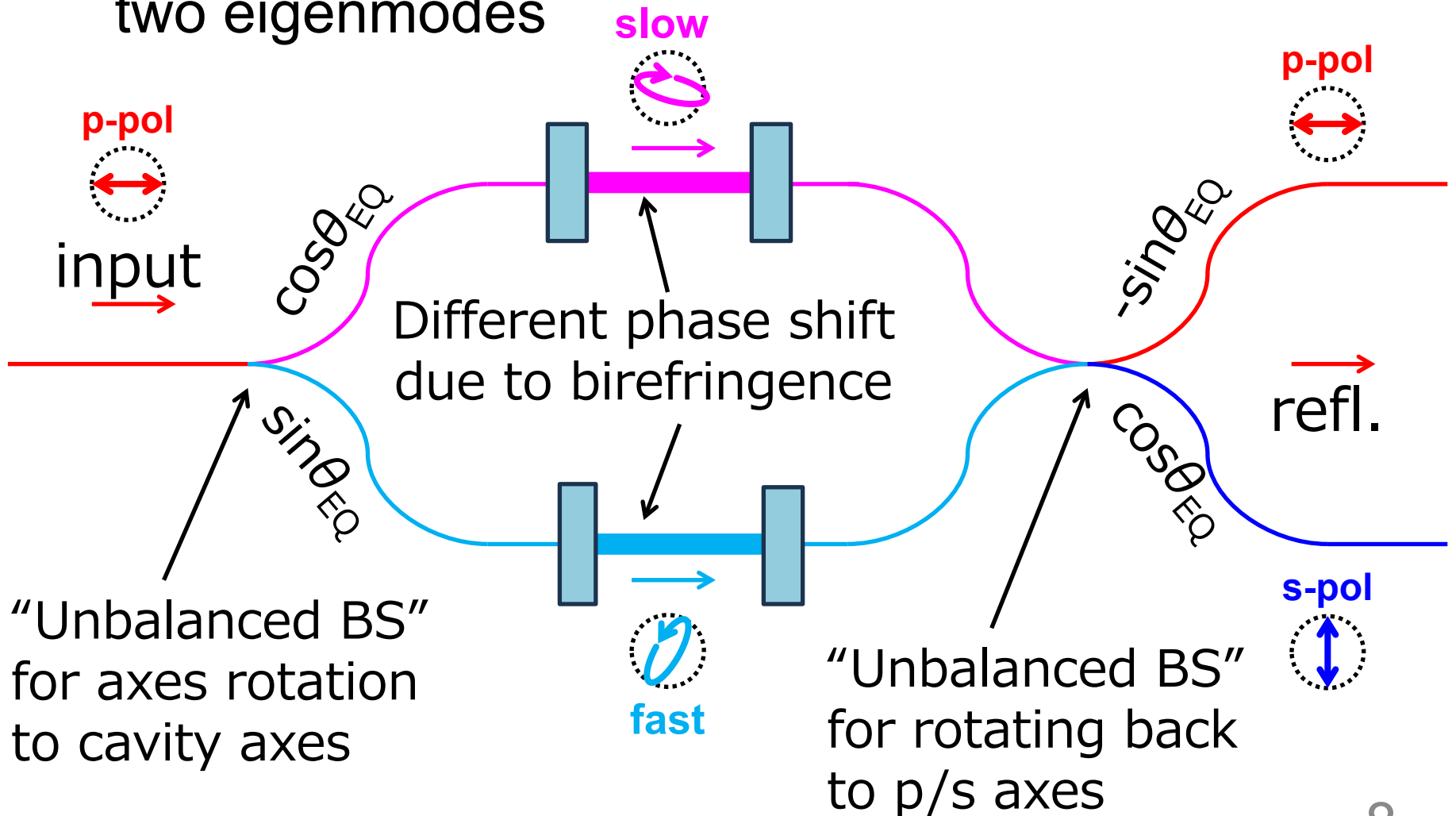
# Birefringent FP Cavity

- FP cavity can be reduced to single “**equivalent waveplate**”



# Birefringent FP Cavity

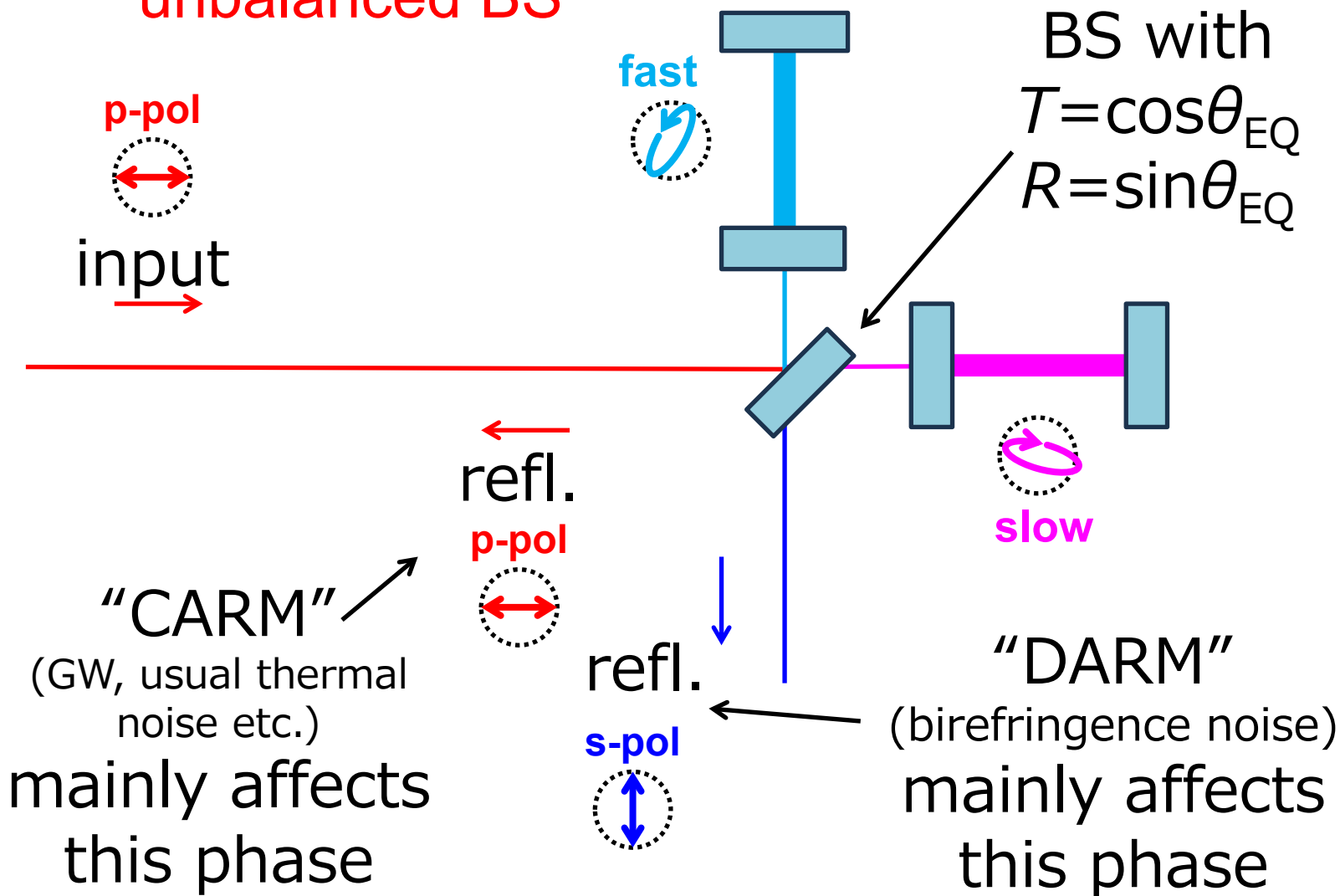
- “Equivalent waveplate” splits input polarization into two eigenmodes





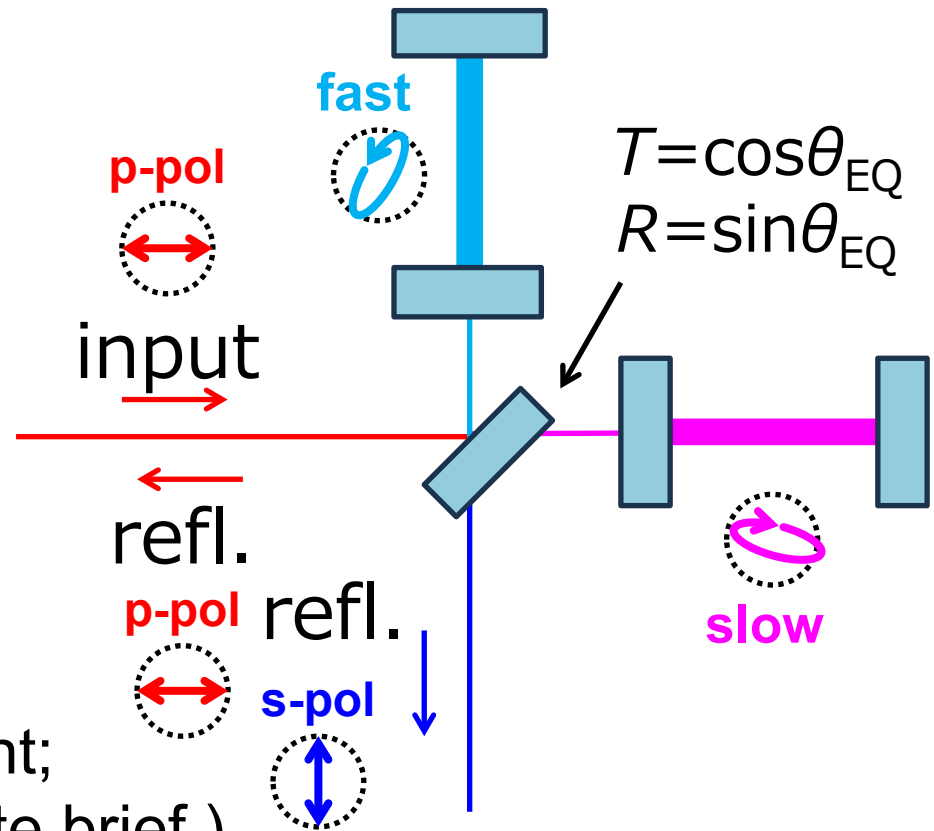
# Birefringent FP Cavity

- So, birefringent FP cavity is equivalent to **FPMI with unbalanced BS**



# Avoiding Birefringence Noise

- “CARM” (GW, usual thermal noise etc.) and “DARM” (birefringence noise) are **mixed** due to unbalanced BS, and therefore **birefringence noise couples** to GW signal
- How to avoid?
  - **Align polarization axis and mirror axes** (make  $\theta_{EQ}=1$ )
  - **Make coating brief.** **large** (make only one of the eigenmodes resonant; would not work for substrate brief.)



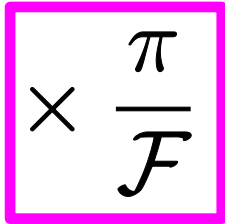
# Requirements for Birefringence

- Displacement noise coupling

$$\frac{\delta L}{\delta(\Delta\phi)} = \frac{\lambda}{4\pi} \sin^2 \theta \times \frac{\pi}{\mathcal{F}}$$

Factor only for substrate birefringence

Angle between polarization axis and cavity axes



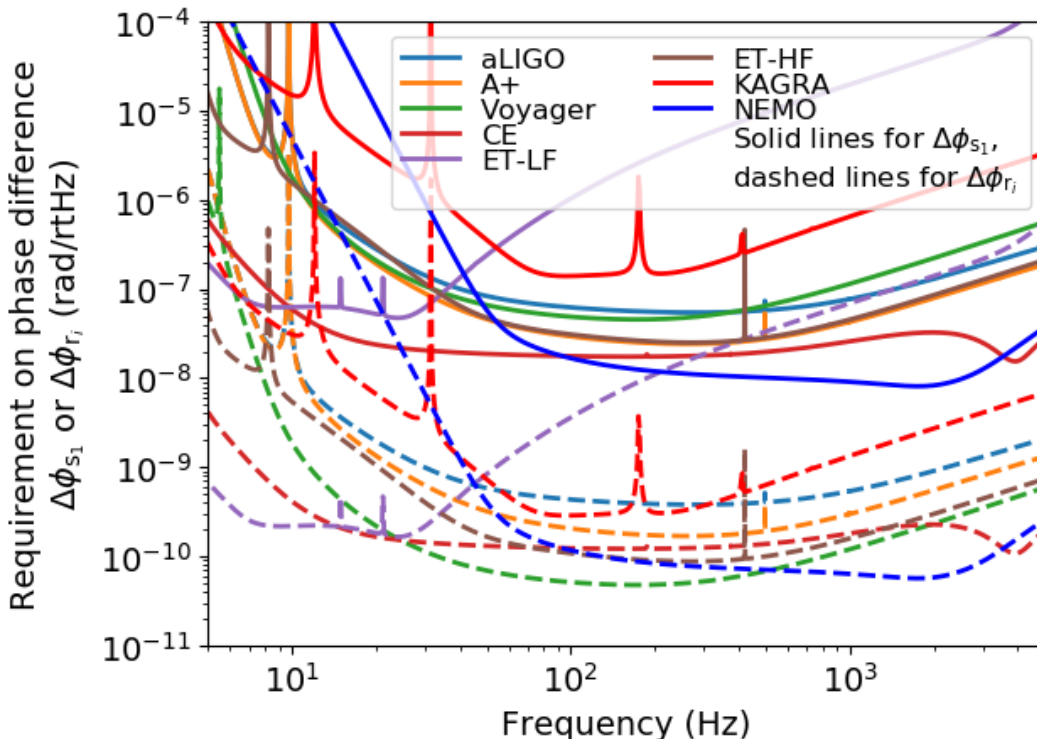
Phase difference between axes

## Requirements on $\Delta\phi$

assuming  $\theta \sim 1$  deg

For substrate  
 $\Delta\phi < \sim 10^{-8}$  rad/ $\sqrt{\text{Hz}}$   
 (or  $\Delta n < \sim 10^{-14}/\sqrt{\text{Hz}}$ )

For coating  
 $\Delta\phi < \sim 10^{-10}$  rad/ $\sqrt{\text{Hz}}$



# Requirements for Axis Rotation

- Displacement noise coupling

$$\frac{\delta L}{\delta \theta} = \frac{\lambda}{4\pi} \Delta\phi \sin 2\theta \times \frac{\pi}{\mathcal{F}}$$

Factor only for substrate birefringence

Phase difference between axes

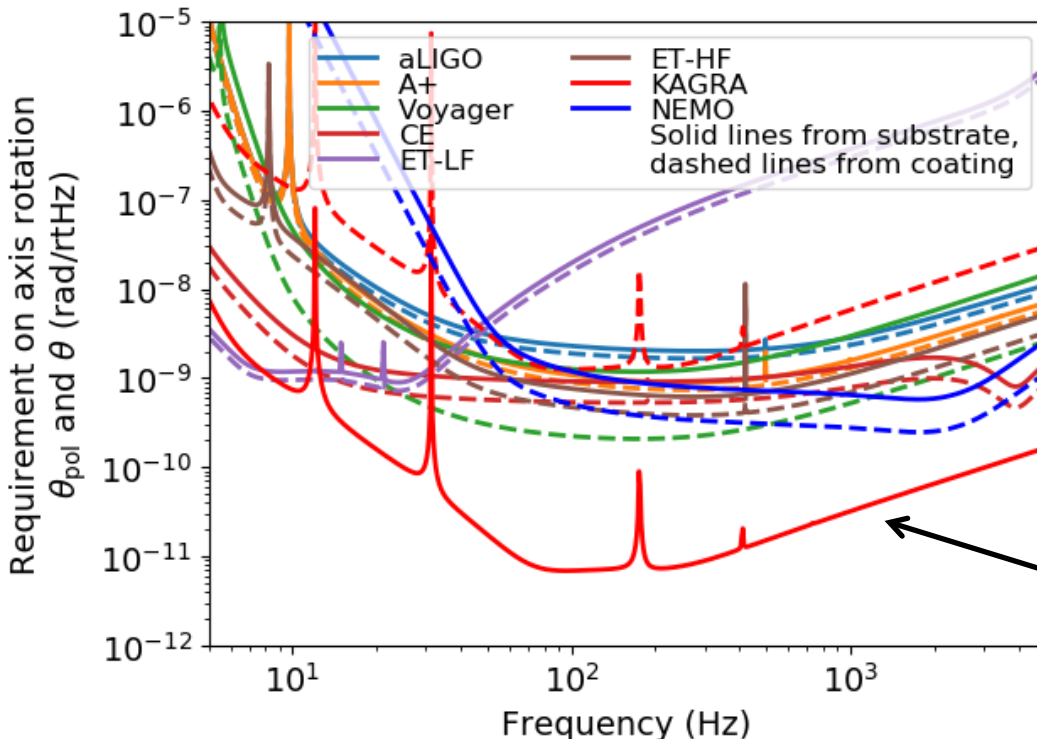
Angle between polarization axis and cavity axes

## Requirements on $\theta$

assuming  $\Delta n \sim 10^{-7}$  or  $10^{-4}$  for substrate,  $\Delta\phi \sim 1$  mrad for coating

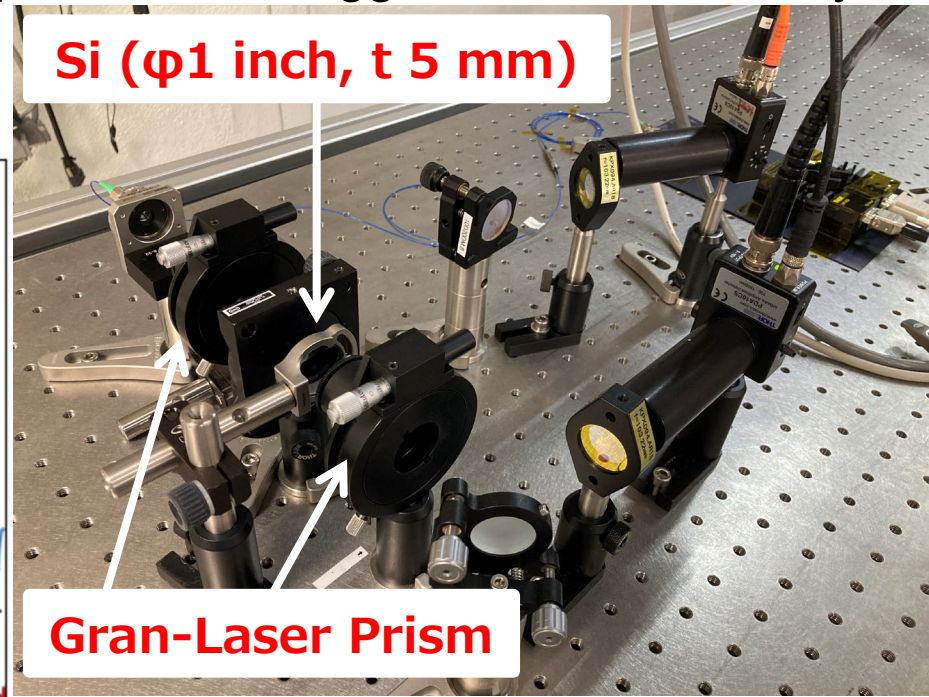
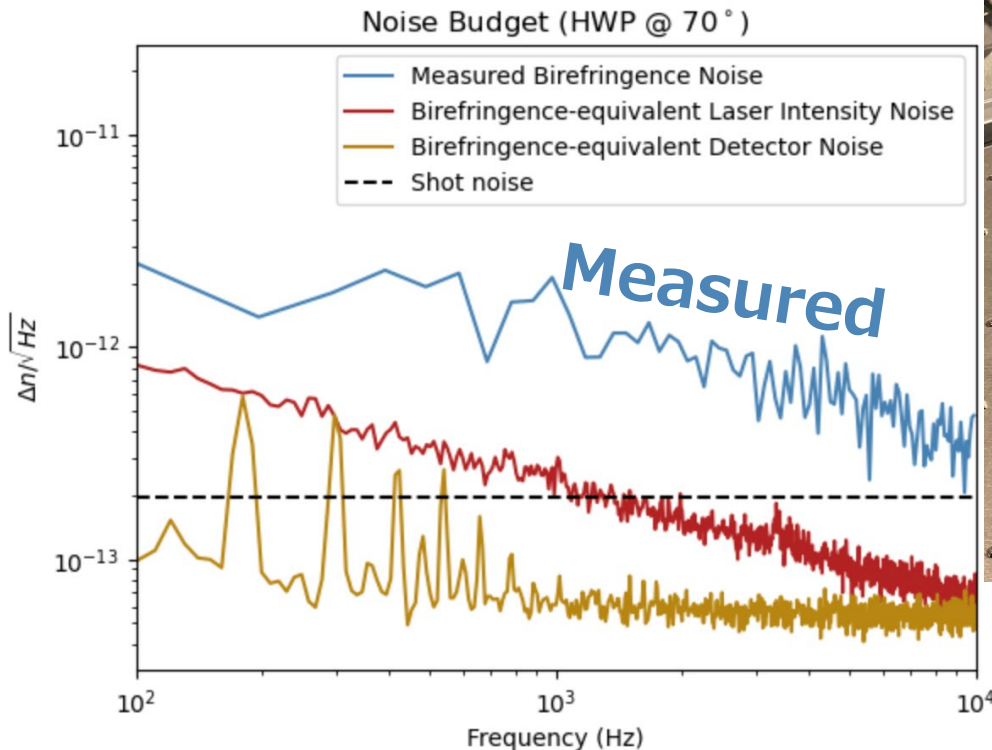
For substrate/coating  
 $\theta < \sim 10^{-10} \text{ rad}/\sqrt{\text{Hz}}$

Strict requirement for KAGRA if  $\Delta n \sim 10^{-4}$  (sapphire)  
 For others, assumed  $\Delta n \sim 10^{-7}$  (e.g. silicon)



# Measurement at Caltech

- Silicon birefringence measurements started
- Sensitivity to  $\Delta n$  of  $2 \times 10^{-12}$  /rtHz @ 100 Hz achieved with Silicon @ 1550 nm, room temp.
  - Measurement at different input polarization suggest this is limited by noise not from silicon



Measurement and plot  
by Kushal Jain

# Summary and Outlook

- **Fluctuations in mirror birefringence** will be phase noises for GW detectors YM+, [arXiv:2308.00150](https://arxiv.org/abs/2308.00150)
- **Measurements of birefringence fluctuations** in Silicon, Sapphire, AlGaAs etc. are necessary to see if they meet the requirement
- Further simulation studies necessary for
  - Investigating **PRC/SRC** effects (unbalanced BS, ITM birefringence)
  - Noise from **inhomogeneous birefringence** x beam spot motion
  - Investigating effects for **squeezing**
  - **Classical radiation pressure noise** from orthogonal pol.